

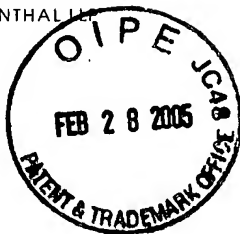
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February 23, 2005

**VIA EMAIL**

Examiner Nguyen

United States Patent and Trademark Office

Commissioner For Patents

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RE: Applicant: Shiro Uchida, et al  
Serial No. 10/821,342, Filed: April 9, 2004  
Title: SEMICONDUCTOR LASER DEVICE AND FABRICATION METHOD THEREOF  
Our Ref. No. 9792909-5918

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Dear Examiner Nguyen:

Thank you for your telephone call yesterday requesting Japanese references disclosed in the PTO-1449 form of the above-identified application.

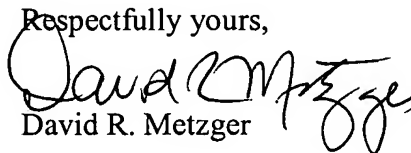
The Japanese references identified in the PTO-1449 form filed on April 9, 2004, are irrelevant to the above-identified application, because the references pertain to a different matter (Docket No. 09792909-5901, Applicants Yutaka Wada, et al.), as indicated in the header of the PTO-1449 form. This form was inadvertently submitted with the Information Disclosure Statement on April 9, 2004. Therefore, the copies you requested, i.e., Japanese references listed on the PTO-1449, are not provided.

A substitute PTO-1449 form which lists the references identified in the Information Disclosure Statement as filed is enclosed herewith. This PTO-1449 correctly identifies the references, which the Applicants wish to be considered and made of record in the above-identified application. The references identified in the Information Disclosure Statement and substitute PTO-1449 are consistent with the references made of record in the parent application (U.S. Serial No. 09/910,617, filed July 20, 2001).


If you have any additional questions regarding this matter please contact us.

SONNENSCHN NATH & ROSENTHAL LLP

Respectfully yours,

  
David R. Metzger

DVM:8XS  
Enclosure

37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)							Docket No. 09792909-5918		Serial No. 10/821,342	
							Applicants: Shiro Uchida, et al.			
							Filing Date April 9, 2004		Group Art Unit	
<b>U.S. PATENT DOCUMENTS</b>										
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate			
	AA	6,414,976	7-2-02	Hirata						
	AB	6,516,016	2-4-03	Fukunaga, et al.						
	AC	6,452,954	9-17-02	Fukunaga						
	AD	2003/0147438	8-7-03	Abeles						
	AE	2003/0012243	1-16-03	Okumura						
	AF									
	AG									
<b>FOREIGN PATENT DOCUMENTS</b>										
		Document Number	Date	Country	Class	Subclass	Translation			
							Yes	No		
	AH	JP2000-196201	7-14-00	Japan			Abstract			
	AI	JP2000-031599	1-28-00	Japan			Abstract			
	AJ	JP11-220210	8-10-99	Japan			Abstract			
	AK									
	AL									
	AM									
	AN									
	AO									
	AP									
	AQ									
	AR									
	AS									
	AT									
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>										
	AU									
	AV									
	AW									
	AX									
	AY									
	AZ									
Examiner				Date Considered						
<b>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</b>										